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- 18. The method of claim 16, further comprising: forming the protective structure to cover sidewalls of the organic photoelectrical conversion structure.
- 19. The method of claim 16, further comprising: forming an organic photoelectrical conversion layer over 5 the first electrode layer;
- removing a portion of the organic photoelectrical conversion layer to form a recess that circumscribes at a perimeter of the organic photoelectrical conversion structure; and
- forming the protective structure to fill the removed portion of the organic photoelectrical conversion structure.

  20. The method of claim 16,
- wherein the organic photoelectrical conversion structure is configured to convert photons having wavelengths 15 falling within a predetermined range into an electrical signal; and
- wherein the second electrode layer is transparent to the photons having wavelengths falling within the predetermined range.

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